

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:	)	
	)	
Franck Delahaye	)	
	)	Examiner: Maki Angadi
	)	
Application Number:	)	
10/599,208	)	Art Unit: 1792
	)	
Filed: September 22, 2006	)	
	)	
For: PROCESS FOR THE WET CHEMICAL	)	
TREATMENT OF ONE SIDE OF	)	
SILICON WAFERS	)	
_____	)	

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Response to Office Action**

Applicant is responding to the Office Action mailed December 8, 2009, which provides a three month shortened statutory period for reply. This response is filed together with a request for continued examination and extension of time under 37 C.F.R. § 1.17(a)(3).

**Amendments to the Claims** are provided on page 2 of this paper.

**Remarks/Arguments** are provided on page 6 of this paper.